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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Sunkara et al.)
)
Filed: November 10, 2003) Examiner:
) Group Art Unit:
Serial No: 10/705,687)
)
For: BULK SYNTHESIS OF METAL AND METAL,)
BASED DIELECTRIC NANOWIRES)
)
Atty. Docket No.: AD138/2001)

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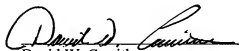
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Applicants(s) submitted herewith patents, publications or other information of which they
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Respectfully submitted,

A handwritten signature in black ink, appearing to read "David W. Carrithers", written over a horizontal line.

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(use as many sheets as necessary)

Complete if Known

Application Number	10/705,687
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Filing Date	November 10, 2003
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First Named Inventor	Mahendra Sunkara
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Art Unit

Examiner Name

Sheet 1

Attorney Docket Number AD138/2001

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER PRIOR ART (Including Author, Title, Date Pertinent Pages, ETC.)

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Examiner Signature	/Edward M. Johnson/ (06/24/2007)	Date Considered	
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